

## SEARCHED

Class	Sub.	Date	Exmr.
L38	706	12/13/162	LV
	710		
	712		
638	720		
	14		
216	57		
	58		
216	59	14/13/162	LV

Dry etching

Marrow  
body

Gas  
phase  
etching

## SEARCH NOTES (INCLUDING SEARCH STRATEGY)

	Date	Exmr.
On first search VII(1) East	11/13/162	LV
Consult with Benjamin Birch regarding of the 62 rejection of Claim 8 specifically about how determine an etch endpoint based on a voltage drop across a resistor as taught in Winnicka reads on changing etching parameters when the voltage across a resistor drops	12/10/162	LV

## INTERFERENCE SEARCHED

Class	Sub.	Date	Exmr.